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### Article

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# A Dual-Point technique for the entire $I_D$ - $V_G$ characterization into subthreshold region under Random Telegraph Noise condition

Xuepeng Zhan, Chengda Shen, Zhigang Ji, Member, IEEE, Jiezhi Chen, Senior Member, IEEE, Hui Fang, Fangbin Guo and Jianfu Zhang

**Abstract**— A simple Dual-Point technique to measure the entire transfer characteristics ( $I_D$ - $V_G$ ) down to sub-threshold region in the nano-scaled MOSFET under Random Telegraph Noise (RTN) condition with either capturing or emitting one elementary charge by a trap in the gate dielectric is proposed. Its compatibility with the commercial semiconductor analyzer makes it a readily-usable tool for future RTN study. In this work, we use this technique to explore the  $V_G$  dependence of RTN induced by a single trapped carrier in both n- and p- FETs.

**Index Terms**—Random Telegraph Noise(RTN), Reliability, Bias Temperature Instability, Time-Dependent Variability.

## I. INTRODUCTION

Random Telegraph Noise (RTN) has become one standard test for future ultra-scaled transistors [1-3]. However, the standard RTN procedure [4] only captures the current under constant gate voltage,  $V_{G,RTN}$ , which contains limited information. Understanding the entire  $I_D$ - $V_G$  curve and its shift induced by the Random Telegraph Noise (RTN) can provide valuable information in understanding its underlying physical mechanism [5-7] and also in the circuit simulation for the time-dependent variability prediction [8, 9]. Usually such measurement is carried out by repeating the standard RTN test procedure under different  $V_G$  levels [10, 11]. However, most RTNs are only clear in narrow voltage range [12], such method cannot probe a broad range of  $I_D$ - $V_G$ . Recently, Franco et. al. [13] tackled this problem by sweeping the entire  $I_D$ - $V_G$  immediately after the RTN test. However, such method requires the rigorous selection of devices that contain only one individual defect with very slow characteristic time and with giant magnitude. This makes the method inapplicable to most of the samples. The recent Trigger-When-Charged method [14]

exploited the oscilloscope-based fast-measurement system in which the edge of RTN is used to trigger the entire  $I_D$ - $V_G$  measurement. But the method requires the dedicated configuration to reduce the background noise. Moreover, the use of the oscilloscope limits the measurement accuracy. Existing RTN models calculate the  $V_G$  dependence of the RTN magnitude theoretically with assumptions, which introduce the inaccuracy for the prediction of RTN-induced noise and their impact in circuits [15]. Therefore, a generic but straightforward characterization technique is urgently required. In this letter, for the first time, we propose a Dual-Point method to fill this gap. The method captures the entire  $I_D$ - $V_G$  down to subthreshold region under RTN condition with any individual trap of characteristic time longer than  $1\mu s$ . This method can be directly deployed in the commercial semiconductor analyzer, making it possible to be used as the standard RTN measurement.

## II. DUAL-POINT CHARACTERIZATION TECHNIQUE

The gate stack of the MOSFETs uses  $SiO_2$  for interlayer,  $HfO_2$  for HK layer, and TiN for work function metal. The equivalent oxide thickness is 1.65 nm. Unless specified, the devices under test have a channel length/width of 70nm/90nm and are all tested under room temperature with drain voltage of 100mV [16]. Keithley 4200 is used for the measurement with the same connection as the standard fast  $I_D$ - $V_G$  configuration: two pulse units are connected with the Gate and Drain while the source and the substrate are grounded. nFETs are used for the demonstration of the technique and both n- and p- FETs are used for the exploration of RTN magnitude.

Capturing the entire  $I_D$ - $V_G$  during RTN requires fast speed that can freeze the trap either in its charged or empty state during the measurement. Due to the low bandwidth in the commercial equipment, the speed for  $I_D$ - $V_G$  measurement at the pulse edge is usually longer than  $20\mu s$  [16]. Moreover, only linear region can be captured due to the poor accuracy. Single-point measurement [17] is an alternative to shorten the measurement time to  $\sim 1\mu s$  while maintaining reasonable accuracy, as shown in Fig.1a. Fig.1b shows one typical result measured in linear region ( $V_{G1} > V_{th}$ ). The RTN-induced current variation,  $\Delta I_D$ , can be clearly observed with time-lag plot [18]. However, when lowering  $V_{G1}$  into subthreshold ( $V_{G1} < V_{th}$ ),  $\Delta I_D$  becomes too small to be differentiated, as shown in Fig.1d&e.

We propose a Dual-Point method to tackle this problem. The new method guarantees the fast measurement speed while

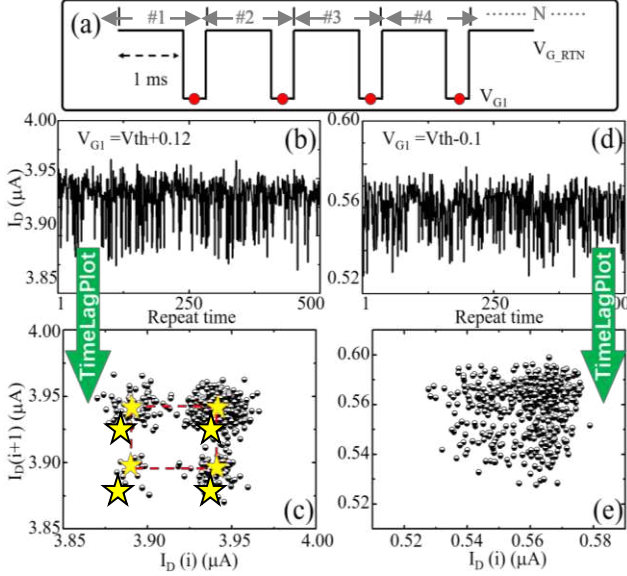
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achieving high accuracy, which allows the  $I_D$ - $V_G$  measurement into subthreshold region under RTN condition.

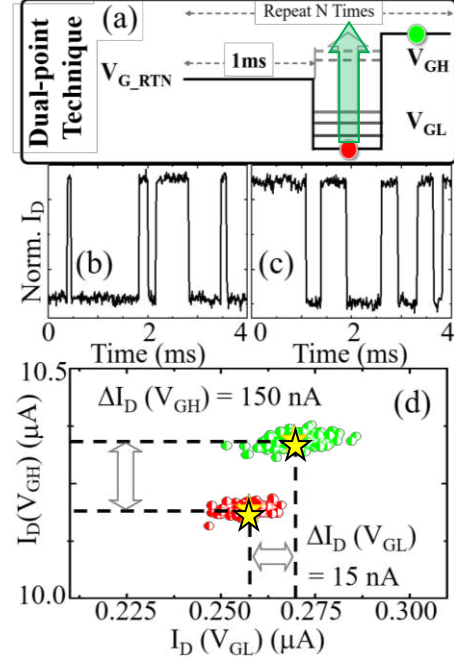


**Fig.1** (a) Gate voltage waveform for measuring RTN-induced current variation at  $V_{G1}$ , that is different from the voltage used for RTN test under  $V_{G,RTN}$ . Currents are measured at (b)  $V_{G1}=0.76$  V ( $>V_{th}$ ) and (d)  $V_{G1}=0.54$  V ( $<V_{th}$ ) after the RTN test under  $V_{G,RTN}=0.65$  V. The corresponding time-lag plot are shown in (c) and (e) respectively. The measurement time,  $t_m$ , of 10 μs is used.

**Fig.2a** shows the waveform of  $V_G$  for the proposed method: After performing the standard RTN test under  $V_{G,RTN}$  for a very short time (1ms in this work),  $V_G$  is altered to  $V_{GL}$  and then  $V_{GH}$  sequentially, in which the drain currents will be measured at each level. At the end of the RTN test, due to its stochastic nature, the single trap will either capture (**Fig.2b**) or emit (**Fig.2c**) one charge carrier and accommodate itself into the charged or empty state. When the follow-on dual-point measurements are fast enough, the charging state of the individual trap will not change: The currents at  $V_{GL}$  and  $V_{GH}$  with the trap in its charged state will always be smaller than the corresponding currents measured with the trap in its empty state. **Fig.2d** shows one typical result by repeating for multiple times. The currents under  $V_{GL}$  is plotted against the values under  $V_{GH}$ . Two clear clusters can be observed suggesting the two states of the trap. In practice, it is possible that the charging state of the trap can change during the measurement. If this happens, the point will lie out of those two clusters. This is rare as confirmed in **Fig.2d**. The centroid of each cluster represents the currents under  $V_{GL}$  or  $V_{GH}$  with the trap in both charged and empty state. We used the iterative k-means clustering algorithm [19] to automate the centroid identification, that also helps minimize the impact of outliers for better accuracy. To capture the entire  $I_D$ - $V_G$ , we repeated the test procedure by fixing  $V_{GH}$  at operating condition and sweeping  $V_{GL}$  from subthreshold region to the linear region. What is worth noting is that since this method freezes the trapping state during the measurement, it is limited to the RTN magnitude extraction. No timing characteristic of the trap (such as capture and emission time) can be extracted.

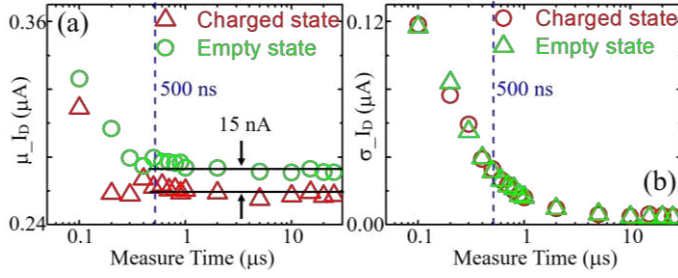
What is worth noticing is that  $\Delta I_D$  of ~15nA at  $V_{GL}$  has been clearly separated. Such success is because the proposed method

measures currents at both  $V_{GL}$  and  $V_{GH}$ , and plotted them against each other. Towards the vertical and horizontal directions,  $\Delta I_D$  represents the current variation in  $V_{GH}$  and  $V_{GL}$  respectively,  $\Delta I_D(V_{GH})$  and  $\Delta I_D(V_{GL})$ . Recent results [20] confirm that  $\Delta I_D$  in linear region is much larger than in subthreshold region. Therefore, the large gap in vertical direction created by  $\Delta I_D(V_{GH})$  makes the two clusters distinguishable even there is tiny gap in the horizontal direction.



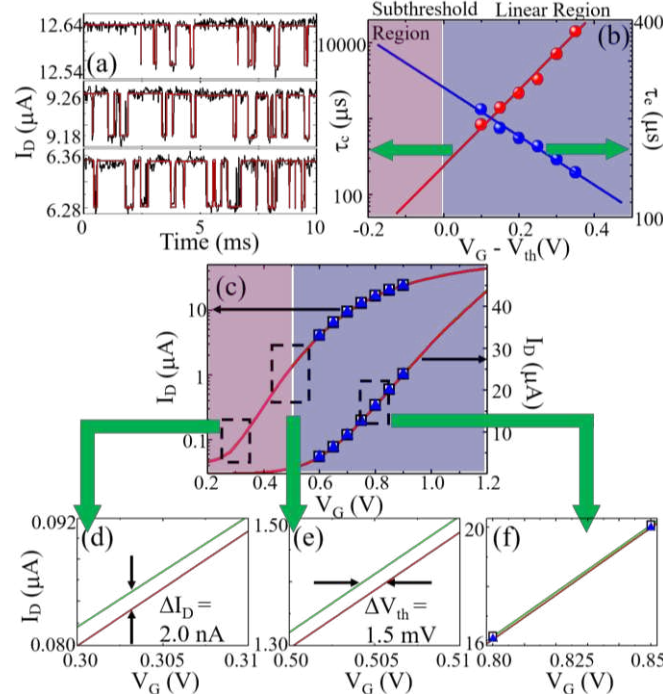
**Fig.2** (a) The waveform for the proposed Dual-Point technique.  $I_D$  are measured at  $V_{GL}$  and  $V_{GH}$ . Two typical RTN results under  $V_{G,RTN} = 0.8$  V are shown in (b) and (c) where the current ends with low or high levels randomly. (d) The relationship between  $I_D$  at  $V_{GL}=0.52$  V and  $V_{GH}=1.10$  V after RTN test under  $V_{G,RTN} = 0.8$  V. Wherein, one point corresponds to one Dual-Point measurement. In total, 500 measurements are repeated.  $t_m$ , of 500ns is used.

The measurement time for each point,  $t_m$ , is further explored. Shorter  $t_m$  increases the chance to freeze the trap during measurement. Moreover, it also reduce the possibility in charging up extra traps at higher voltage level. For simplicity but without loss of generality, we use the current measured at  $V_{GL}$  for the discussion. **Fig.3a&b** show the average value ( $\mu_{I_D}$ ) and the variation ( $\sigma_{I_D}$ ).  $\mu_{I_D}$  determines the accuracy of the method. As shown in **Fig.3a**,  $\mu_{I_D}$  at the charged and empty state keep constant until  $t_m$  reduces to 500ns. When  $t_m$  further decreases,  $\mu_{I_D}$  starts to rise. This is because  $t_m$  is shorter than the settle time that  $V_G$  is not yet lowered down to  $V_{GL}$ . Such speed ensures the method can be applied on RTN traps with the characteristic time larger than  $\sim 1$  μs. The corresponding  $\sigma_{I_D}$  are shown in **Fig.3b**, which increases monotonically with shorter  $t_m$ . However,  $\sigma_{I_D}$  will not limit the measurement resolution of the proposed method. With the speed of 500ns,  $\sigma_{I_D}$  is  $\sim 25$  nA. This guarantees the separation with  $\Delta I_D$  over  $\sim 50$  nA, that can be met by most samples under  $V_{GH}$  in linear region. The two clusters therefore can be separated vertically even they have small difference horizontally under  $V_{GL}$ , as confirmed in **Fig.3a** that 15nA ( $<\sigma_{I_D}$ ) can be clearly separated.



**Fig.3** The impact of the measurement time,  $t_m$ , on (a) the average value and (b) the standard deviation of  $I_D$ .

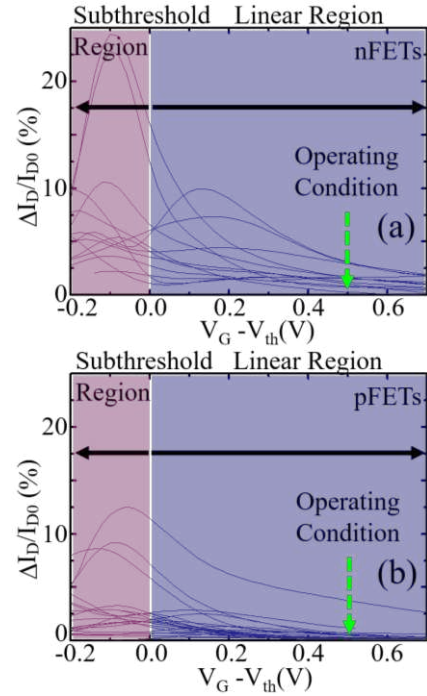
Finally, **Fig.4a-f** shows one example for the RTN magnitude extraction with the proposed method. Standard RTN method can only characterize a limited range of  $V_G$ , as shown in **Fig.4a**.  $V_G$  dependence of the corresponding capture/emission time in **Fig.4b** suggests that this trap is fast: At subthreshold and linear region, the electron detrapping and trapping can occur with less than 200 $\mu$ s respectively. **Fig.4c** shows the extracted  $I_D$ - $V_G$  curves using our proposed method: the two curves correspond to this single trap in the empty and charged state respectively. It is clear that both curves can be measured down to subthreshold region. As enlarged in **Fig.4d&e**, the  $\Delta V_{th}$  of 1.5mV and  $\Delta I_D$  of 2nA can be clearly identified with the proposed method. What is also worth noting is that within the measurement window of the standard RTN method, the two methods agree very well with each other, as enlarged in **Fig.4f**. However, the new method has much wider window from subthreshold to operating condition.



**Fig.4** (a) RTN measurement under constant voltage from 0.75V to 0.65V downwards with a step of 0.05V. Both the magnitude and the capture/emission time are extracted with HMM fitting (red line). (b)  $V_G$  dependence for the capture/emission time and their extrapolation into subthreshold region. (c) The two entire  $I_D$ - $V_G$  curves captured under the RTN condition are plotted in both linear and log scale. The current extracted from the standard RTN method is also plotted as points for comparison with the enlargement in (f). The region in the subthreshold and linear domain are enlarged in (d) and (e). The RTN-induced threshold voltage shift of  $\sim 1.5$  mV and  $\Delta I_D$  of 2nA can be clearly separated.

### III. APPLICATIONS TO RTN STUDY IN NANO-SCALED DEVICE

In this section, we applied the Dual-Point method to explore the  $V_G$  dependence of the RTN magnitude. By convention [9], the RTN magnitude is defined as  $\Delta I_D/I_{D0}$  under constant  $V_G$ , where  $I_{D0}$  is the drain current with the single trap at its empty state.  $\Delta I_D/I_{D0}$  against  $V_G$  from multiple nano-scaled p- and n- FETs are shown in **Fig.5a&b** respectively. Overall, nFET exhibits the larger  $\Delta I_D/I_{D0}$  variations compared with pFETs, which agrees with some recent reports [21, 22]. It is not clear yet whether this is a general phenomenon and future investigations are needed. Our result also shows that  $\Delta I_D/I_{D0}$  are larger around threshold region and reduce towards the operating region. This agrees well with the 3D atomic simulation results by assuming different distances between individual traps in the dielectric and the percolation path in the channel induced by the non-uniform doping [23]. Since the standard RTN test measures  $\Delta I_D/I_{D0}$  close to threshold region, this result suggests that the time-dependent variation could be overestimated [24]. Therefore, the measurement of the entire  $I_D$ - $V_G$  under the RTN condition is essential.



**Fig.5**  $V_G$  dependence of  $\Delta I_D/I_{D0}$  induced by individual traps under RTN condition on (a) nFETs and (b) pFETs.  $t_m$  of 500ns is used.

### IV. CONCLUSION

We developed a simple Dual-Point technique that can be directly deployed in the commercial semiconductor analyzer. The accuracy and precision of the method is discussed in details. The proposed technique can be used to capture the wide range of  $I_D$ - $V_G$  from the subthreshold region up to device operating condition. With its fast measurement speed of 500ns, the technique can be applied on most of the devices that contains single traps in the dielectric. Finally, we applied this method to evaluate the  $V_G$  dependence of the impact of a single trapped carrier in both n- and p- FETs.



## REFERENCES

- 1.S. Dongaonkar, M. D. Giles, A. Kornfeld, B. Grossnickle, and J. Yoon. "Random telegraph noise (RTN) in 14nm logic technology: High volume data extraction and analysis". Proc. IEEE VLSI Technol., pp.1-2, 2016, doi: [10.1109/VLSIT.2016.7573424](https://doi.org/10.1109/VLSIT.2016.7573424)
- 2.N. Tega, H. Miki, Z. Ren, C. P. D'Emic, Y. Zhu, N., D. J. Frank, M. A. Guillorn, D.-G. Park, W. Haensch, and K.Torii, "Impact of HK / MG stacks and future device scaling on RTN." Proc. IEEE IRPS., pp. 6A.5.1-6A.5.6, 2011, doi: [10.1109/IRPS.2011.5784546](https://doi.org/10.1109/IRPS.2011.5784546)
3. L. Pirro, O. Zimmerhackl, A. Zaka, L. Miiller-Meskamp, R. Nelluri, T. Hermann, I. Cortes-Mayol, A. Huschka, M. Otto, E. Nowak, A. Mittal, and J. Hoentschel, "RTN and LFN Noise Performance in Advanced FDSOI Technology". Proc. 48th Eur. Solid State Device Res. Conf., pp. 254-257, 2018, doi: [10.1109/ESSDERC.2018.8486917](https://doi.org/10.1109/ESSDERC.2018.8486917)
4. M. J. Uren, D. J. Day, and M.J. Kirton, "1/f and random telegraph noise in silicon metal-oxide-semiconductor-field-effect transistors". Appl. Phys. Lett., vol. 47, no. 11, pp.1195-1197, 1985, doi.org/10.1063/1.96325
5. K. P. Cheung, and J. P. Campbell. "On the magnitude of Random telegraph noise in ultra-scaled MOSFETs." Proc. IEEE Int. Conf. IC Design Technol. (ICICDT), pp.1-4, 2011, doi: [10.1109/ICICDT.2011.5783191](https://doi.org/10.1109/ICICDT.2011.5783191)
6. C. Chen, Q. Huang, J. Zhu, Y. Zhao, L. Guo, and R. Huang, "New Understanding of Random Telegraph Noise Amplitude in Tunnel FETs" IEEE Electron Device Lett., vol.64, no. 8, pp. 3324-3330, 2017, doi: [10.1109/TED.2017.2712714](https://doi.org/10.1109/TED.2017.2712714)
7. I. Zadorozhnyi, J. Li, S. Pub, H. Hlukhova, V. Handziuk, Y. Kutovyi, M. Petrychuk, and S. Vitusevich, "Effect of Gamma Irradiation on Dynamics of Charge Exchange Processes between Single Trap and Nanowire Channel." Small, vol. 14, no.2, pp. 1702516, 2018, doi.org/10.1002/sml.201702516
8. M. Luo, R. Wang, S. Guo, J. Wang, J. Zou, and R. Huang, M., "Impacts of Random Telegraph Noise (RTN) on Digital Circuits". IEEE Trans. Electron Devices, vol. 62, no. 6, pp. 1725-1732, 2014, doi: [10.1109/TED.2014.2368191](https://doi.org/10.1109/TED.2014.2368191)
9. M. L. Fan, S. Y. Yang, V. P. H. Hu, Y. N. Chen, P. Su, C. T. Chuang, "Single-trap-induced random telegraph noise for FinFET, Si/Ge Nanowire FET, Tunnel FET, SRAM and logic circuits". Microelectronics Reliability, vol. 54, no. 4, pp. 698-711, 2014, doi.org/10.1016/j.microrel.2013.12.026
10. K.K. Hung, P. K. Ko, C. Hu, and Y. C. Cheng, "Random telegraph noise of deep-submicrometer MOSFETs". IEEE Electron Device Lett., vol.11, no. 2, pp. 90-92, 1990, doi: [10.1109/55.46938](https://doi.org/10.1109/55.46938)
11. J. Brown, R. Gao, Z. Ji, J. Chen, J. Wu, J. Zhang, B. Zhou, Q. Shi, J. Crawford, W. Zhang, "A low-power and high-speed True Random Number Generator using generated RTN.", Pro IEEE VLSI Technol., pp.95-96, 2018, doi: [10.1109/VLSIT.2018.8510671](https://doi.org/10.1109/VLSIT.2018.8510671).
12. C. Chen, Q. Ran, H. Cho, A. Kerber, Y. Liu, M. R. Lin, and R. W. Dutton, "Correlation of Id- and Ig-random telegraph noise to positive bias temperature instability in scaled high-k/metal gate n-type MOSFETs." Proc. IEEE IRPS., pp.3A.2.1-3A.2.6, 2011, doi: [10.1109/IRPS.2011.5784475](https://doi.org/10.1109/IRPS.2011.5784475)
13. J. Franco, B. Kaczer, M. Toledano-Luque, Rh. J. Roussel, J. Mitard, L.-Å. Ragnarsson, L. Witters, T. Chiarella, M. Togo, N. Horiguchi, G. Groeseneken, M. F. Bukhori, T. Grasser and A. Asenov, "Impact of single charged gate oxide defects on the performance and scaling of nanoscaled FETs", Proc. IEEE IRPS., pp.5A.4.1-5A.4.6, 2012, doi: [10.1109/IRPS.2012.6241841](https://doi.org/10.1109/IRPS.2012.6241841)
14. A. Manut, R. Gao, J. Zhang, Z. Ji, M. Mehedi, W. Zhang, V. David, A. Asenov, B. Kaczer., "Trigger-When-Charged: A technique for directly measuring RTN-induced threshold voltage fluctuation under use-Vdd." IEEE Trans. Electron Devices, 2019.(In press)
15. J. S. Kolhatkar, E. Hoekstra, C. Salm, A. P. van der Wel, E. A. M. Klumperink, J. Schmitz and H. Wallinga, "Modelling of RTS Noise in MOSFETs under Steady-state and Large Signal," IEDM, pp. 759-762, 2005, doi: [10.1109/IEDM.2004.1419283](https://doi.org/10.1109/IEDM.2004.1419283)
16. Z. Ji, D. Linten, R. Boschke, G. Hellings, S. H. Chen, A. Alian, D. Zhou, and Y. Mols, T. Ivanov, J. Franco, B. Kaczer, X. Zhang, R. Gao, J. F. Zhang, W. Zhang, N. Collaert, G. Groeseneken, "ESD characterization of planar InGaAs devices", Proc. IEEE IRPS., pp. 3F.1.1-3F.1.7., 2015, doi: [10.1109/IRPS.2015.7112719](https://doi.org/10.1109/IRPS.2015.7112719).
17. R. Wang, J. Zou, X. Xu, C. Liu, J. Liu, H. Wu, Y. Wang, and R. Huang, " New observations on the AC random telegraph noise (AC RTN) in nano-MOSFETs", Proc. IEEE VLSI Technol., pp.1-2, 2012, doi: [10.1109/VLSI-TSA.2012.6210146](https://doi.org/10.1109/VLSI-TSA.2012.6210146).
- 18.T. Nagumo, K. Takeuchi, S. Yokogawa, K. Imai, and Y. Hayashi, "New analysis methods for comprehensive understanding of Random Telegraph Noise", Proc. IEDM Tech., pp.1-4, 2009, doi: [10.1109/IEDM.2009.5424230](https://doi.org/10.1109/IEDM.2009.5424230).
19. G. Gan, and M. K.-P. Ng, "k-means clustering with outlier removal". Pattern Recognition Letters, vol. 90, pp. 8-14, 2017, doi.org/10.1016/j.patrec.2017.03.008.
20. N. Tega, H. Miki, Z. Ren, C. P. D'Emic, Y. Zhu, D. J. Frank, M. A. Guillorn, D. -G. Park, W. Haensch and K. Torii, "Impact of HK/MG stack and Future Device Scaling on RTN," in IEEE International Reliability Physics Symposium (IRPS), pp. 630-635, 2011, doi: [10.1109/IRPS.2011.5784546](https://doi.org/10.1109/IRPS.2011.5784546)
- 21 A. Whitcombe, S. Taylar, M. Denham, V. Milovanovic and B. Nikolic, "On-Chip I-V Variability and Random Telegraph Noise Characterization in 28nm CMOS," in Proceedings of the European Solid-State Device Research Conference (ESSDERC), pp. 248-251, 2016, doi: [10.1109/ESSDERC.2016.7599632](https://doi.org/10.1109/ESSDERC.2016.7599632)
- 22 S. Dongaonkar, M. D. Giles, A. Kornfeld, B. Grossnickle, J. Yoon, "Random Telegraph Noise (RTN) in 14nm Logic Technology: High Volume Data Extraction and Analysis," in Symposia on VLSI Technology (VLSI), pp. 978-979, 2016, doi: [10.1109/VLSIT.2016.7573424](https://doi.org/10.1109/VLSIT.2016.7573424).
23. R. Wang, S. Guo, Z. Zhang, Q. Wang, D. Wu, J. Wang, and R. Huang, "Too Noisy at the Bottom? —Random Telegraph Noise (RTN) in Advanced Logic Devices and Circuits." Proc. IEEE IEDM Tech. pp.17.2.1-17.2.4, 2018, doi: [10.1109/IEDM.2018.8614594](https://doi.org/10.1109/IEDM.2018.8614594)
24. T. Komawaki, M. Yabuuchi, R. Kishida, J. Furuta, T. Matsumoto, and K. Kobayashi, "Circuit-level simulation methodology for Random Telegraph Noise by using Verilog-AMS," Proc. IEEE Int. Conf. IC Design Technol. (ICICDT), pp.1-4, 2017, doi: [10.1109/ICICDT.2017.7993526](https://doi.org/10.1109/ICICDT.2017.7993526).